

<b>Notice of References Cited</b>	Application/Control No. 10/721,470	Applicant(s)/Patent Under Reexamination IWABUCHI, TOMOYUKI	
	Examiner Dung Nguyen	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,023,310	02-2000	Kawamoto et al.	349/54
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	K	US-			
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	M	US-			

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**NON-PATENT DOCUMENTS**

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